Docket No.: 085027-0106 PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Customer Number: 89518

Hui-Mei Chen, et al. Confirmation Number: 3341

Application No.: 10/786,807 Group Art Unit: 2822

Filed: February 25, 2004 Examiner: Bac H. Au

For METHOD FOR IMPROVING SEMICONDUCTOR WAFER TEST ACCURACY

TRANSMITTAL.

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

CERTIFICATE OF ELECTRONIC TRANSMISSION Thereby certify that this correspondence is being electronicallytransmitted to the United States Patent and Trademark Office on November 20, 2009 /Tobi Terry/

Dear Sir:

Tobi Terry

Transmitted herewith is an Amendment in the above-identified application. Also attached: Petition for a One-Month Extension of Time

The fee has been calculated as shown hel-

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	8	20	0	\$52.00 =	\$0.00
Independent Claims	3	3	0	\$220.00 =	\$0.00
		Multiple dependent claims newly presented			\$0.00
		Fee for One-Month	Fee for One-Month Extension of Time		
					\$0.00
			Total of Above Calculations		\$130.00

- Please charge my Deposit Account No. 502624 in the amount of \$130.00. An additional copy of this transmittal sheet is submitted herewith.
- The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 502624, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

/Dennis A. Duchene/ Dennis A. Duchene Registration No. 40,595

11682 El Camino Real, Suite 400 San Diego, CA 92130 Phone: 858,720,3300 DAD:tt

Facsimile: 858 720 7800 Date: November 20, 2009 Please recognize our Customer No. 89518 as our correspondence address.